New Opportunities for Gallium Nitride in Power, Sensing and RF

Rob Harper Compound Semiconductor Centre



Some Opening Comments

- There used to be a saying 'GaN is the material of the future and always will be.'
- It wasn't long ago and implied that we would never get to where we are today.
- But for GaN Power
 - Market forecasts for >\$2 Billion industry by 2028.
 - Huge capacity expansions and M&A across the whole supply chain.
 - Forecast for >928K GaN epi wafers per year (6" equivalent) by 2028.
- It helped that Zero Carbon initiatives pushed the need for high efficiency PE.
- There is now growing confidence in the maturing GaN supply chain.
- This opens new opportunities for GaN in existing Si and GaAs applications as well as new areas where Si can't compete.



Presentation Outline

- What makes GaN special? Key Properties
- Comparative Figures of Merit for Power and RF.
- Epitaxial GaN HEMTs Challenges and Substrate Choice.
- Market Challenges and New Opportunities.
- Gan for Wireless, Harsh Environment Sensing.
- Conclusion Where will GaN win new market share?



So What Makes GaN Special?

- It's the combination of wide band gap and 2 dimensional electron gas (2DEG) that makes GaN perfect for high power and high speed switching.
- Combination of spontaneous and piezo-electric polarisation results in a discontinuity at the AlGaN/GaN interface, leading to a 2DEG.
- High sheet carrier density can be tailored by increasing Al composition and thickness of AlGaN barrier.
- For 25% Al and 20nm typical Ns = 7.7E12 cm-2.
- Charge carriers without doping no scattering losses!
- Results in high electron mobility



Power Semiconductor Materials

Properties	Si	SiC(4H)	GaN
Crystal Structure	Diamond	Hexagonal	Hexagonal
Energy Gap (eV)	1.12	3.26	3.4
Breakdown Field (Ecrit) (V.cm x 10 ⁶)	0.3	2.8	3
Electron Mobility (cm ² /V.s)	1400	900	1250
Electron Mobility (device)	1000	<100	1500 - 3000
Thermal Conductivity (W/cm°C)	1.5	4.9	1.3
Baliga FOM = $\underline{\textbf{EoEr}} \times \mu \times \textbf{Ecrit}^3$	1	675	3000

RF Semiconductor Materials

Property	Si	GaAs	GaN
Bandgap (eV)	1.1	1.42	3.4
Saturation Velocity cm/s x 10 ⁷	1.0	1.2	1.0
Critical Field Ecrit (MV/cm)	0.3	0.4	3.0
Johnson FOM (normalised to Si)	1	2.7	27.5
Thermal Conductivity (W/cm-K)	1.5	0.46	1.7

Advantages of GaN and other WBG materials over Silicon

Unipolar Limit

$$R_{DS,on} \cdot A = \frac{4 V_B^2}{\varepsilon_0 \varepsilon_r \mu E_{crit}^3}$$

Baliga FOM

- **E**_{crit} is the dominant materials parameter for R_{DS,on}.A for a given breakdown voltage.
- Higher breakdown fields means high voltage can be supported with much thinner material.
- Huge improvement in R_{DS,on} (on-resistance).
- Reduction in resistive losses. (Heat).





If GaN is better than SiC – Why isn't it bigger than SiC ?

- Most of the challenges relating to GaN devices are attributable to the challenges of hetero-epitaxy.
- Large diameter bulk GaN wafers are not currently available (Though they could be soon).
- Bulk SiC wafers have been available since 1991 (Cree) enabling >30 years of device development.
- Defects related to lattice mismatch and differences in coefficients of thermal expansion degrades performance and reliability.
- We have engineered ways to mitigate this but it ultimately limits device performance.
- Bulk GaN promises to be a total game changer especially for vertical power devices ≥ 1200V.

Parameter	Si	Sapphire	SiC	GaN
Lattice mismatch	-17%	-33%	3.5%	0
Thermal Mismatch	116%	-23%	24%	0
TDD (/cm ²)	~10 ⁹	~10 ⁹	$\sim 10^{7}$	$\sim 10^{4}$





Bow Control





WBG Substrate Availability/ Maturity Versus Silicon



Si boule





- Silicon is a mature technology

 wafers are easy to
 manufacture at low cost.
- SiC much more challenging but now mainstream.
- 150mm bulk GaN wafers forecast by 2025 from Mitsubishi. (2023 estimate)



SCAAT[™]-LP 2-inch+ crystal



SCAAT[™]-LP 4-inch+ crystal

ENGINEERED SUBSTRATES

- Smart-cut enabled substrates can provide novel solutions:
 - **QST** (Qromis Substrate Technology) is CTE matched to GaN enabling thicker layers of GaN to be grown without bowing or cracking.
 - **SmartSiC** is already in production at Soitec. Bernin 4.
 - **SmartGaN** is in development and will consist of a high quality GaN layer on a silicon or nonsilicon handle wafer.
 - It will address the power market above 1200V and high frequency RF.



New Opportunities in Automotive (CAGR forecast 110% 2022-

APC Power Roadmap





How do we get to >1200V? - Transition from Lateral to Vertical Devices

Lateral GaN HEMT



- Voltage scaling requires significant increase to chip area.
- More semiconductor real-estate required.
- HEMT structure based on 2DEG.
- Hetero-epitaxy is extremely challenging.
- Dynamic Ron is still an issue at High Voltage

Vertical GaN Trench FET



- Voltage scaling without increasing chip area.
- Breakdown voltage can be increased by increasing drift region thickness.
- Improved power density.
- Route to lower cost.
- Requires complex doping of GaN epi structure.
- Immature substrate technology (Bulk GaN)

- RF market matured ahead of Power.
- Market dynamics different to Power (IDM vs Foundry)
- 4" GaN on Semi-insulating SiC slowly transitioning to 6".
- Slower growth projections (CAGR forecast 12% 2022-28)
- Compare this to power (CAGR forecast 49%)
- Traditional markets (Telecom, Defence, Satcom).
- Difficult to displace incumbent Si and GaAs device technologies.
- Challenging for cost to compete against mature supply chains.
- Needs to provide performance advantages and compete at system level for cost.

The length of the gate determines the speed of the device

Source and drain contacts provide lowresistance access to the intrinsic device.



The mechanical and thermal properties of the device are dominated by the substrate. High-power dissipation devices benefit from a substrate with high thermal conductivity. SiC better than Si. Diamond better still.



- So where is GaN winning out?
 - Applications where it offers performance advantages Increased bandwidth, Improved PAE, Improved thermal conductivity and ruggedness, Smaller form factor, Radiation hardness.
- GaN devices can be operated at much higher voltages than competing RF technologies (Si and GaAs). GaN can therefore produce more RF power in a given die area than any other semiconductor material.
- Telecoms for RAN applications the TCO is impacted by ~40% of the energy consumption coming from the RU (radio unit).
- This impact will increase with the evolution of cellular technology as data loads and energy consumption grows.
- For satellite applications radiation hardness is highly desirable whether for PSU, motor-drives, sensors and RF PAs for satellite based 5G (Space X).



New Applications in Ultra High-Sensitivity Current and Positional Sensing

The Hall Effect.



 $V_{H} = K_{H}.B.I$

Where

The sensitivity (K_H) of the sensor is given by $K_H = 1/t.n.e$ where:

t = thickness,

n = electron concentration

e = electron charge.

- 2DEGs are orders of magnitude thinner than silicon CMOS Hall effect devices and have higher carrier concentrations.
- They are therefore able to provide far higher resolution magnetic field measurements over a wide range of operating environments.
- Other significant benefits of GaN's wider band gap include radiation hardness and high temperature tolerance which makes such devices suitable for harsh environments including space and high radiation, high-temperature applications.



Summary and Takeaways

- GaN is no longer a material of the future but very much of the present.
- It would have been so much better if we'd had a cost effective bulk substrate 30 years ago (like SiC).
- However, bulk GaN and Engineered GaN substrates could be game changing (but there's still a way to go).
- GaN will become more cost effective (especially at the system level) as supply chains mature.
- This will enable it to compete with incumbent technologies in both Power and RF as well as new applications where Si and GaAs can't compete.

Thanks For Your Attention

